PATENT Customer No. 22,852 Attorney Docket No. 04329.3100

OCT 3 1 2007 BY

Sir:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

oplication of:	
Kei HAYASAKI et al.) Group Art Unit: 1756
tion No. 10/624,593	Examiner: Duda, Kathleen
July 23, 2003) Confirmation No. 7500
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	Kei HAYASAKI et al. tion No. 10/624,593 July 23, 2003 METHOD FOR FORMING A PATTERN AND SUBSTRATE- PROCESSING APPARATUS op RCE ssioner for Patents

PETITION FOR EXTENSION OF TIME

Applicants petition for a two month extension of time to file a reply to the Final Office Action mailed June 1, 2007. A fee of \$460 is included with this filing.

Please grant any additional extensions of time required to enter the attached reply and charge any additional required fees to our Deposit Account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: October 31, 2007

David M. Longo

Reg. No. 53,235

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